

APPLICATION DATA SHEET

APPLICATION INFORMATION

Application Type:: REGULAR
Subject Matter:: UTILITY
CD-ROM or CD-R?:: NONE
Title:: SEMICONDUCTOR DEVICE AND ITS
MANUFACTURING METHOD
Attorney Docket Number:: 263878US2PCT
Total Drawing Sheets:: 12

INVENTOR INFORMATION

Applicant Authority Type:: INVENTOR
Primary Citizenship Country:: Japan
Status:: FULL CAPACITY
Given Name:: Kenji
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Country of Residence:: Japan
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Applicant Authority Type:: INVENTOR
Primary Citizenship Country:: Japan
Status:: FULL CAPACITY
Given Name:: Junji
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CORRESPONDENCE INFORMATION

Correspondence Customer Number:: 22850

REPRESENTATIVE INFORMATION

Representative Customer Number:: 22850

DOMESTIC PRIORITY INFORMATION

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	National Stage of	PCT/JP03/08146	06/26/03

FOREIGN PRIORITY INFORMATION

Application Number:	Country::	Filing Date::	Priority Claimed::
2002-189161	Japan	06/28/02	YES

ASSIGNMENT INFORMATION

Assignee Name:: National Institute of Advanced Indust Sci
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Street of Mailing Address:: 3-1, Kasumigaseki 1-chome, Chiyoda-ku
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